#### PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of	Docket No: Q77851
Hiroo TAKIZAWA, et al.	in the same and the
Appln, No.: 10/678,301	Group Art Unit: 1756
Confirmation No.: 4148	Examiner: Martin J. Angebranndt
Filed: October 6, 2003	

For: NON-RESONANT TWO-PHOTON ABSORBING MATERIAL, NON-RESONANT TWO-PHOTON EMITTING MATERIAL, AND METHOD FOR INDUCING ABSORPTION OR GENERATING EMISSION OF NON-RESONANT TWO PHOTONS BY USING THE MATERIAL

## AMENDMENT UNDER 37 C.F.R. § 1.114(e)

#### MAIL STOP RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 22, 2006, please amend the aboveidentified application as follows on the accompanying pages.

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